DECLARATION FOR PATENT APPLICATION

As below named inventor, I hereby declare that:

My residence, post office address and citizenship are as stated below next to my name.

I believe I am the original inventor of the subject matter which is claimed and for which a patent is sought on the invention entitled:

CONTOUR INSPECTION METHOD AND APPARATUS

the specification of which (check one)

is attached hereto.			
was filed by an authorized person on my behalf on			
as Application Serial No.			
and was amended on .			
(if applicable)			

I hereby state that I have reviewed and understand the contents of the above-identified specification, including the claims as amended by any amendment referred to above.

I acknowledge the duty to disclose information which is material to the examination of this application in accordance with Title 37, Code of Federal Regulations, §1.56(a).

I hereby claim foreign priority benefits under Title 35, United States Code, §119 of any foreign application(s) for patent or inventor's certificate listed below and so identified, and I have also identified below any foreign application for patent or inventor's certificate on this invention filed by me or my legal representatives or assigns and having a filing date before that of the application on which priority is claimed.

Priority

			Claimed
Number	Country	Day/Month/Year Filed	(Yes or No)
2000-323187	Japan	23 October 2000	Yes

I hereby claim the benefit under Title 35, United States Code, §120 of any United States application(s) listed below and, insofar as the subject matter of each of the claims of this application is not disclosed in the prior United States application in the manner provided by the first paragraph of Title 35, United States Code, §112, I acknowledge the duty to disclose material information as defined in Title 37, Code of Federal Regulations, §1.56(a) which occurred between the filing date of the prior application and the national or PCT international filing date of this application:

I hereby declare that all statements made herein of our own knowledge are true and that all statements made on information and belief are believed to be true; and further that these statements were made with the knowledge that willful false statements and the like so made are punishable by fine or imprisonment, or both, under §1001 of Title 18 of the United States Code and that such willful false statements may jeopardize the validity of the application or any patent issued thereon.

I hereby appoint the following attorneys and patent agents, with full power of substitution and revocation, to prosecute this application and to transact all business in the United States Patent and Trademark Office connected therewith and request that all correspondence and telephone calls in respect to this application be directed to:

Keiichi Nishimura, BEYER WEAVER & THOMAS, LLP P.O. Box 778 Berkeley, CA 94704-0778 Telephone: (510) 843-6200 Facsimile: (510) 843-6203

Steve D Beyer, Reg. No. 31,234 Jeffrey K. Weaver, Reg. No. 31,314 C. Douglass Thomas, Reg. No. 32,947 James E. Austin, Reg. No. 39,489 Joseph M. Villeneuve, Reg. No. 37,460 Jonathan O. Scott, Reg. No. 39,364 Michael J. Ferrazano, Reg. No. 44,105 Michael L. Louie, Reg. No. 36,988 Mary R. Olynick, Reg. No. 42,963 Quin Hoellwarth, Reg. No. 45,738 Phillip Lee, Reg. No. P46,866 Lisa Norris, Reg. No. 44,976 Russell N. Swerdon, Reg. No. 36,943 Frank T. Kalinski, II, Reg. No. 44,177 Elise R. Heilbrunn, Reg. No. 42,649 Dean E. Wolf, Reg. No. 37,260 Ramin Mahboubian, Reg. No. 44,890 James W. Rose, Reg. No. 34,239 Michael B. Lee, Reg. No. 31,846 Godfrey Kwan, Reg. No. 46,850 Lauren L. Stevens, Reg. No. 36,691 Keiichi Nishimura, Reg. No. 29,093

Full name of inventor: Inventor's signature: Date:	Shiro Fujieda Shiro Fujieda 29 day of September, 2001.
Residence:	Kyoto, Japan
Post Office Address:	c/o OMRON Corporation 801 Minamifudodo-cho, Horikawahigashiiru Shiokoji-dori, Shimogyo-ku, Kyoto, Japan
Citizenship:	Japan

OMRN.P009